IFW



PATENT Customer No. 22,852 Attorney Docket No. 4329.2509-01

## IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

n re Application of:	)
Kazuya SATO et al.	) )
Application No.: 10/806,448	) Group Art Unit: 2877
Filed: March 23, 2004	) Examiner: Tu T. Nguyen
For: METHOD FOR INSPECTING EXPOSURE APPARATUS	) ) )

Commissioner for Patents P.O. Box 1450 Alexandria, VA 22313-1450

Sir:

## **REPLY TO OFFICE ACTION**

In reply to the January 11, 2005 Office Action, please amend the above-identified application as follows:

Amendments to the claims are reflected in the listing of claims in this paper.

Remarks follow the amendment section of this paper.